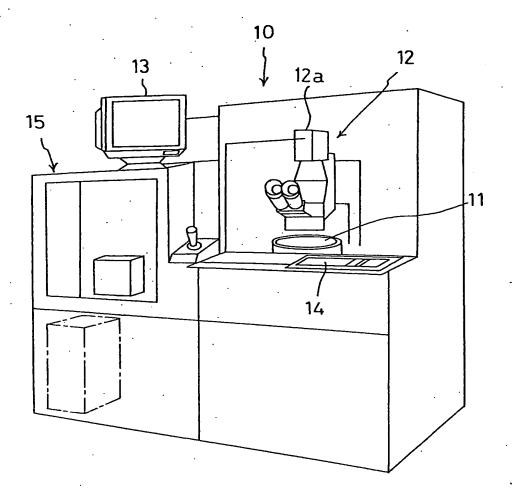
APPLN. FILING DATE: NOVEMBER 15, 2005
TITLE: OUTER SURFACE-INSPECTING METHOD, MASTER
PATTERNS USED THEREFOR, AND OUTER SURFACEINSPECTING APPARATUS EQUIPPED WITH SUCH A
MASTER PATTERN (AS AMENDED)
INVENTOR(S): SHIGEYUKI AKIMOTO ET AL.
ATTY. DKT. No.: 034398-004

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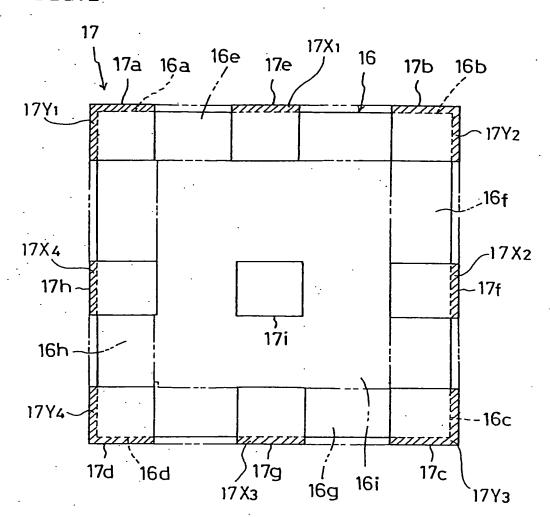
FIG.1



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TITLE: OUTER SURFACE-INSPECTING METHOD, MASTER PATTERNS USED THEREFOR, AND OUTER SURFACE-INSPECTING APPARATUS EQUIPPED WITH SUCH A MASTER PATTERN (AS AMENDED)
INVENTOR(S): SHIGEYUKI AKIMOTO ET AL.
ATTY. DKT. NO.: 034398-004

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FIG.2



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TITLE: OUTER SURFACE-INSPECTING METHOD, MASTER PATTERNS USED THEREFOR, AND OUTER SURFACE-INSPECTING APPARATUS EQUIPPED WITH SUCH A MASTER PATTERN (AS AMENDED)
INVENTOR(S): SHIGEYUKI AKIMOTO ET AL.
ATTY. DKT. NO.: 034398-004

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FIG.3

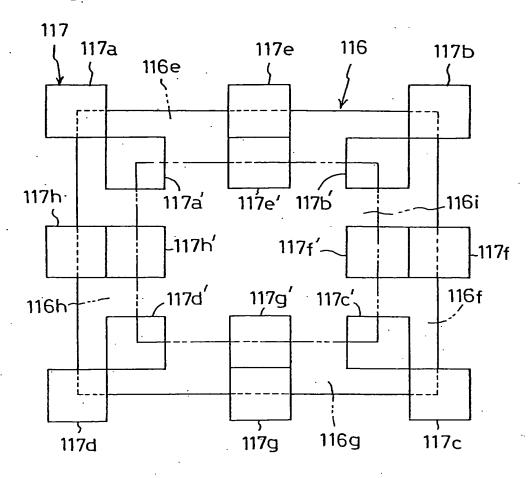
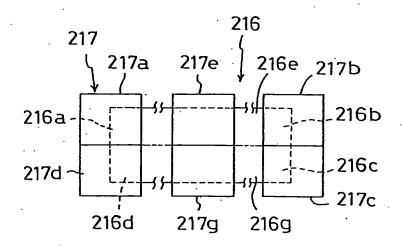


FIG.4



APPLN. FILING DATE: NOVEMBER 15, 2005
TITLE: OUTER SURFACE-INSPECTING METHOD, MASTER PATTERNS USED THEREFOR, AND OUTER SURFACE-INSPECTING APPARATUS EQUIPPED WITH SUCH A MASTER PATTERN (AS AMENDED)
INVENTOR(S): SHIGEYUKI AKIMOTO ET AL.
ATTY. DKT. NO.: 034398-004
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FIG.5

